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Void Formation and Structure Change Induced by Heavy Ion Irradiation in GaSb and InSb

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Void formation and structure change by heavy ion irradiation were investigated in GaSb and InSb thin films. The voids were formed after irradiation in both materials. The average diameter of the voids was about 15 nm in GaSb and 20 nm in InSb irradiated with 60 keV Sn⁺ ions to a fluence of 0.25 × 10¹⁸ ions/m² at room temperature. The void size in InSb is larger than that in GaSb. The large void size is quantitatively explained by the amount of induced vacancies obtained by the SRIM code simulation. The Debye-Scherrer rings were observed in the SAED patterns on both materials. The structure changes into a polycrystal by ion irradiation. Additionally, the 200 superlattice reflections in the [001] direction were almost absent, and the streak pattern along the [110] direction was observed in InSb. It is considered that the anti phase domains of different lengths are formed by ion irradiation. Ion irradiation transforms the structure of InSb from chemical ordering to chemical disordering via the formation of anti phase boundaries. [doi:10.2320/matertrans.M2010037]

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1. Introduction

Defect structure formation in III-V compound semiconductors induced by ion irradiation is classified into three categories. In the case of a typical defect structure, for example, GaAs¹–⁵ and InP,⁶,⁷ a damaged layer corresponding to the projected ion range is formed on the surface by ion irradiation; further irradiation transforms the damaged layer into an amorphous structure. Si is an elemental semiconductor classified into this category. In the case of GaN,⁸–¹⁰ nitrogen bubbles and gallium nanocrystals are formed in the amorphized layer by ion irradiation. In the case of GaSb⁹–¹⁷ and InSb⁹,¹⁷,¹⁸ unusual behaviors, such as elevation, swelling, and the formation of holes, voids, nanofibers, and cellular structures with nano to submicron dimensions, are observed on irradiated surfaces. Similar phenomena occur in irradiated Ge surfaces (for example, see Refs. 19–27). It is clarified that such anomalous phenomena occur as a result of the movement of point defects induced by ion irradiation, and these structures are generated after void formation. These phenomena have been reported in relation to bulk irradiation. Thin film irradiation will yield some useful knowledge on the movement of point defects utilizing surface sinks; however there are few studies on GaSb and InSb. In this study, void formation in the early stage of such structures and structure change by ion irradiation were investigated in GaSb and InSb thin films using transmission electron microscopy (TEM). In addition, structures formed in GaSb were compared with those formed in InSb in order to investigate the effect of the constituent elements.

2. Experimental Procedures

Single crystals of GaSb and InSb were supplied in the form of wafers 450 mm thick with the (001) normal. Discs of about 3 mm diameter were cut from the wafer, and a dimple was formed at the central portion of the discs. Then the disks were thinned by ion milling with argon for TEM observation. Sn⁺ ion irradiation of 60 keV was performed for thin film samples using a heavy ion accelerator. The projected ion range was 25 nm in GaSb and 27 nm in InSb, obtained by the stopping and range of ions in matter (SRIM) code simulation.²⁸ The temperature of irradiation was 300 K. The ion fluence and flux were 0.25 × 10¹⁸–2 × 10¹⁸ ions/m² and 3 × 10¹¹ ions/m² respectively. The observation was carried out with a transmission electron microscope (HITACHI H-7000 and HF-2000) operated at 125 kV and 200 kV.

3. Results and Discussion

Figure 1 shows TEM images (bright-field image) and their selected area electron diffraction (SAED) patterns of GaSb before and after irradiation. The direction of observation is [001]. The size of a SAED aperture is 1 μm². Voids were formed in each sample after irradiation. The average diameter of the voids was about 14 nm in the sample irradiated to a fluence of 0.25 × 10¹⁸ ions/m² (Fig. 1(b)). The density of voids was 3 × 10¹⁵ voids/m². The swelling ratio of voids was 9% (a damage level of approximately 0.75 dpa). The diameter of voids grew to 23 nm in the sample irradiated to a fluence of 0.5 × 10¹⁸ ions/m² (Fig. 1(c)). The density of voids was 2 × 10¹⁵ voids/m². Despite the increasing ion fluence, the density decreased, which seems to be due to the coalescence of several voids. The swelling of voids increased up to 24% (a damage level of approx-
approximately 1.5 dpa). The average diameter, density, and swelling ratio of the voids were about 22 nm, $2 \times 10^{15}$ voids/m$^2$, and 24% (a damage level of approximately 3 dpa) in the $1 \times 10^{18}$ ions/m$^2$ sample (Fig. 1(d)), and about 21 nm, $2 \times 10^{15}$ voids/m$^2$, and 17% (a damage level of approximately 6 dpa) in the $2 \times 10^{18}$ ions/m$^2$ sample (Fig. 1(e)), respectively. With increasing ion fluence, the diameter of the voids increased under low irradiation fluences. However, the diameter did not change significantly under high irradiation fluences. It is considered that newly formed voids play a role in the surface sink. The formed interstitials and vacancies escape to the void surface; therefore, voids do not grow under high irradiation fluences. The Debye-Scherrer rings were observed in the SAED patterns. These rings can be indexed as the 111, 220, and 311 reflections of crystalline GaSb. The structure became polycrystalline after ion irradiation.

Figure 2 shows TEM images (bright-field image) and their SAED patterns of InSb before and after irradiation. The average diameter, density, and swelling ratio of the voids were about 20 nm, $2 \times 10^{15}$ voids/m$^2$, and 16% (a damage level of approximately 3 dpa) in the $0.25 \times 10^{18}$ ions/m$^2$ sample (Fig. 2(b)). The density of voids was $2 \times 10^{15}$ voids/m$^2$. The swelling ratio of voids was 16%. In the sample irradiated to a fluence of $0.5 \times 10^{18}$ ions/m$^2$ (Fig. 2(c)), the diameter of voids grew to 26 nm. The density of voids was $1 \times 10^{15}$ voids/m$^2$. The swelling of voids was 19%. The average diameter, density, and swelling ratio of the voids were about 26 nm, $1 \times 10^{15}$ voids/m$^2$, and 17% in the $1 \times 10^{18}$ ions/m$^2$ sample (Fig. 2(d)), and about 29 nm, $1 \times 10^{15}$ voids/m$^2$, and 22% in the $2 \times 10^{18}$ ions/m$^2$ sample (Fig. 2(e)), respectively. There is the same as that tendency of GaSb under low and high irradiation fluences. The Debye-Scherrer rings were also observed in the SAED patterns. In the sample irradiated to a fluence of $2 \times 10^{18}$ ions/m$^2$, the width of the Debye-Scherrer rings is broad compared with that of GaSb. The 200 superlattice reflections in the [001] net pattern of InSb are almost absent. This indicated that chemical disordering was induced by the irradiation of InSb. Additionally, the streak pattern along the (110) direction was observed around 200 superlattice reflections, which was slightly rotated from the original direction.

Changes in the diameter of voids in GaSb and InSb as a function of ion fluence are shown in Fig. 3. The void size in InSb is larger than that in GaSb. The void size of InSb irradiated to a fluence of $0.25 \times 10^{18}$ ions/m$^2$ is 1.4 times larger than that in GaSb. The number of vacancies in GaSb and InSb are obtained using the SRIM code simulation. Here we adopted the values of displacement threshold energy obtained by Thommen for GaSb (6.2 eV for Ga and 7.5 eV for Sb), and by Bauerlein for InSb (5.8 eV for In and 6.8 eV for Sb). The calculated average production of vacancies per 60 keV Sn$^+$ ion is about 4450 in GaSb and 4980 in InSb. The local vacancy concentration in InSb is 1.2 times as high as that in GaSb. The large void is explained on the basis of the results of the quantitative evaluation of vacancies existing in InSb. The enthalpy of formation ($\Delta H$) is $-42$ kJ/mol in GaSb and $-31$ kJ/mol in InSb. It is also explained that the vacancy concentration in InSb is much higher than that in GaSb. Furthermore, the atomic diffusion by irradiation has been studied intensively by many researches (for example, see Refs. 32 and 33). The irradiation-induced diffusion is the positional exchange between an atom and a vacancy induced by irradiation, therefore, the rate of migration.
strongly depends on the vacancy concentration and its inhomogeneous distribution. The concentration of vacancy in InSb is higher than that in GaSb. It is expected that the irradiation-induced diffusion in InSb is faster than that in GaSb. The relation between atomic diffusion and diameter of void has been showed by Hishinuma et al.\textsuperscript{34} The solution treated Type 316 stainless steel was 1 MeV electron irradiated at 643–903 K. With increasing irradiated temperature, the void size is increased. It shows that the migration of the point defect enhances the growth of void. Those results may be adapted in irradiated GaSb and InSb. It is also explained that the diameter of the voids in InSb is larger than that in GaSb.

Figure 4 shows an example of high resolution (HR) images and their corresponding fast Fourier transform (FFT) patterns of InSb irradiated to a fluence of $0.25 \times 10^{18}$ ions/m$^2$. The local crystal structure in InSb is analyzed by FFT of the HR images to investigate the streak pattern in Fig. 2, since the diameter of the SAED aperture installed in the TEM is too large to obtain the local diffraction pattern. The analysis region is 25 nm × 25 nm. The direction of observation is [001]. In the FFT patterns, many diffraction spots were observed around 200 superlattice reflections. The fluctuation confirmed the location of the diffraction spots. It became evident that the streak pattern is an accumulation of those spots. Figure 5 shows schematic illustrations of (a) a diffraction pattern around the 200 superlattice reflection and (b) an anti phase boundary in a zincblende structure. It is well known that the quadruple satellite spots around superlattice reflections obtained the electron diffraction analysis are for quenched CuAu II alloy.\textsuperscript{35} The phenomena could be clearly interpreted by the formation of anti phase domains. It is considered that the observed spots in Figs. 4(a′)–(c′) are similar to the above phenomena. The parameter $M$, the size of anti phase domains measured in atomic distance, is given, in general, as a fractional number from diffraction patterns.\textsuperscript{35} For example, Fig. 5(b) shows the size of the anti phase domain to be $M = 2$. The streak pattern consisting of many spots is observed in Fig. 2. It indicates that anti phase domains of different lengths are formed by ion irradiation. The streak pattern exists the distances of reciprocal lattice
of 1/2–1/12 along the direction of \(h_{110}\). Therefore it is explained that the anti phase boundary introduced random at 2–17 times longer than the InSb unit cell along the direction of \(h_{110}\). This finding indicates that ion irradiation transforms the InSb structure from chemical ordering to chemical disordering via the formation of anti phase boundaries. It is considered that the differences in the void formation and structure change between GaSb and InSb are caused by the difference in the behaviors of point defects. The behavior might be caused by the difference in the stoichiometry of GaSb and InSb.

4. Conclusions

Void formation and structure change induced by heavy ion irradiation in GaSb and InSb have been studied by TEM. The void size in InSb is larger than that in GaSb. The large void is explained on the basis of the results of the quantitative evaluation of vacancies existing in InSb. Ion irradiation transforms the structure of InSb from chemical ordering to chemical disordering via the formation of anti phase boundaries.

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